

#9 BAF/1752

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

is the application of

Kenichiro SATO, et al.

Attorney Docket No.: Q58614

Appln. No. 09/541,597

Group Art Unit: 1752

Confirmation No.: Unknown

Examiner: R. ASHTON

Filed: April 3, 2000

For: POSITIVE PHOTORESIST COMPOSITION FOR FAR ULTRAVIOLET  
EXPOSURE

RECEIVED  
NOV 26 2001  
TC 1700

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

ATTN: BOX AF  
Commissioner for Patents  
Washington, D.C. 20231

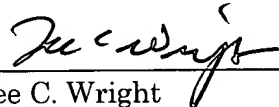
Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of July 23, 2001 to November 23, 2001.

**Please charge the statutory fee of \$110.00 to Deposit Account No. 19-4880.**

Please charge any additional fees under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

  
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